03560.002758



2 851 Application

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)		
Ryuichi ÉBINUMA et al.	: Examiner: H. Nguyen		
Application No.: 09/817,018	: Group Art Unit: 2851		
Filed: March 27, 2001	; )		
For: SUPPORTING STRUCTURE OF OPTICAL ELEMENT, EXPOSURE APPARATUS HAVING THE SAME, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	: ) April 24, 2003 : )	VECHNOLOGY	
Commissioner for Patents		NPR 40L00	갦
Washington, D.C. 20231		R 29	CE
Sir:		9 2003 CENTER	RECLIVEL
Transmitted herewith is an Amendment in the above-identif	fied application.	3 R 2800	·
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X No additional fee is required.

The fee has been calculated as shown below:

			CLAIMS AS AME	ENDED		
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	33	MINUS	51	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	4	MINUS	4	= 0	x \$42 \$84	\$0.00
Fee for Multip	ple Dependent claims	\$140/\$280				
			TOTAL ADDITIONS FOR THIS AMEN			\$0.00

°Verified Statement claiming small entity status is enclosed, if not filed pre	viously
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	A check in the amount of \$ is enclosed including the additional claims fees.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a two month extension is enclosed.
X	A check in the amount of \$180.00 to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants Steven E. Warner Registration No. 33,326
FITZPAT	TRICK, CELLA, HARPER & SCINTO

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200 SEW/eab

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PATENT APPLICATION

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Robert ?
Drawer

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Commissioner for Patents Washington, D.C. 20231

## REQUEST FOR APPROVAL OF DRAWING CHANGES

Sir:

Applicants request that the Examiner approve the changes to Figures 3, 5, 7-9 and 11, as shown in red on the attached sketches, enclosed in duplicate.

In Figure 3, "ADHESSIVE" should read -- ADHESIVE --, as shown.

In Figure 5, "ADHESSIVE" should read -- ADHESIVE --, as shown.

In Figure 7, "ADHESSIVE" should read -- ADHESIVE --, as shown.

In Figure 8, both instances of "ADHESSIVE" should read -- ADHESIVE --, as

shown.

In Figure 9, both instances of "ADHESSIVE" should read -- ADHESIVE --, as shown.

In Figure 11, under "FIG. 11," insert -- PRIOR ART --.

Favorable consideration is requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010 All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

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